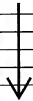


Form PTO 1449 (Modified)		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY DOCKET NO. 277078US0PCT		SERIAL NO. 10/550,534	
LIST OF REFERENCES CITED BY APPLICANT				APPLICANT Kentarou TAMAKI, et al.			
				FILING DATE September 22, 2005		GROUP 2874	
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
		AA					
		AB					
		AC					
		AD					
		AE					
		AF					
		AG					
		AH					
		AI					
		AJ					
		AK					
		AL					
		AM					
		AN					
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION YES      NO		
/MJS/ 	AO	JP 2000-66051	3/3/2000	Japan (with English Abstract)		X	
	AP	JP 2001-83342	3/30/2001	Japan (with English Abstract)		X	
	AQ	JP 63-194206	8/11/1988	Japan		X	
	AR	JP 61-260208	11/18/1986	Japan		X	
	AS	WO 03/010603 A1	2/6/2003	WIPO (with English Abstract)		X	
	AT	JP 10-268158	10/9/1998	Japan (with English Abstract)		X	
	AU	CN 1285667 A	2/28/2001	China		X	
	AV						
OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, etc.)							
/MJS/	AW	Kentarou TAMAKI, et al. " Photolithographic Properties of Photosensitive Sol-gel Materials and their Application to Optical Waveguides", Journal of Photopolymer Science and Technology Volume 15, Number 1, 2002, Pages 103-108					
	AX						
	AY						
	AZ						
Examiner					<input type="checkbox"/> Additional References sheet(s) attached		
/Michael Stahl/					Date Considered 01/27/2008		

\*Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.